



IFW

Attorney Docket no: 0553-0164.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yamazaki et al.

Serial No.: 10/651,458

Filed: August 29, 2003

For: Semiconductor Device And Method of
Fabricating The Same

Examiner: Thao X. Le

Art Unit: 2814

I hereby certify that this correspondence
is being deposited with the United States
Postal Service as first class mail in an
envelope addressed to:
Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on 1/24/05

Shannon Wallace

Date: January 24, 2005

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT C

In response to the Office Action of October 29, 2004, please amend the above-identified
application as follows:

IN THE TITLE:

Please replace the title with the following amended title:

~~Semiconductor~~ Display Device ~~And Method of Fabricating The Same~~